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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/775,517	02/09/2004	Don Michael	200314165	1062
22879 7590 11/27/2007 HEWLETT PACKARD COMPANY P O BOX 272400, 3404 E. HARMONY ROAD			EXAMINER	
			FULK, STEVEN J	
	JAL PROPERTY ADMINISTRATION NS, CO 80527-2400		ART UNIT	PAPER NUMBER
	·, · · · · · · · · · · · · · · · · ·		· 2891	
			MAIL DATE	DELIVERY MODE
			11/27/2007	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

		<i>TH</i>
	Application No.	Applicant(s)
Office Action Summary	10/775,517	MICHAEL ET AL.
Office Action Summary	Examiner	Art Unit
The MAU INC DATE of this areas in the	Steven J. Fulk	2891
The MAILING DATE of this communication apperiod for Reply	pears on the cover sheet wi	ith the correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailine earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNION 136(a). In no event, however, may a result of the specific state	CATION. eply be timely filed ITHS from the mailing date of this communication. ANDONED (35 U.S.C. 8.133)
Status		
 Responsive to communication(s) filed on 12 S This action is FINAL. 2b) This Since this application is in condition for allowated closed in accordance with the practice under the second se	s action is non-final. ance except for formal matt	
Disposition of Claims		
4) ⊠ Claim(s) <u>1-16,24-50 and 54-62</u> is/are pending 4a) Of the above claim(s) <u>6,8-16,30,31,48-50 and 55)</u> Solution Claim(s) <u>32-42</u> is/are allowed. 6) ⊠ Claim(s) <u>1-5,7,24-29,43-47,54,55,57,58,60 and 70</u> Solution Claim(s) <u>59 and 62</u> is/are objected to. 8) □ Claim(s) <u>are subject to restriction and/or subject to restriction and/or</u>	<u>and 56</u> is/are withdrawn fro a <u>nd 61</u> is/are rejected.	om consideration.
Application Papers		
9) The specification is objected to by the Examine 10) The drawing(s) filed on <u>09 February 2004</u> is/ar Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Examine 11.	re: a) \boxtimes accepted or b) \square or drawing(s) be held in abeyaretion is required if the drawing	nce. See 37 CFR 1.85(a). (s) is objected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		•
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Burea * See the attached detailed Office action for a list	ts have been received. ts have been received in A prity documents have been nu (PCT Rule 17.2(a)).	pplication No received in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	Paper No(s	Summary (PTO-413) s)/Mail Date nformal Patent Application

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 1-5, 7, 24-29, 43-47, 54-55, 57-58 and 60-61 are rejected under 35 U.S.C. 102(e) as being anticipated by Michael et al. '283.

The applied reference has a common inventor with the instant application. Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

Regarding claims 1, 2, 57 and 58, Michael discloses a package for a microelectromechanical device (MEMS package), comprising: an inner enclosure having an inner cavity defined therein (fig. 2, inner enclosure 100); and a fill port channel (120) communicating with the inner cavity and of sufficient length to allow a quantity of adhesive to enter the fill port channel while preventing the adhesive 10/775,517

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from entering the inner cavity, wherein the fill port channel extends at least partially into the inner enclosure (bottom of channel 120 extends into cavity); further comprising a fluid filling the inner enclosure (fig. 4, 400) and an airless interface between the fluid and adhesive (fig. 9, airless interface).

Regarding claims 3 and 7, the reference further discloses the package to comprise a flow control structure extending at least partially into the fill port channel (fig. 8, flow control structures 740 and 600) and wherein the flow control structure comprises a peninsula (740) and prevents the adhesive from entering the cavity by physically obstructing a portion of the fill port channel (600).

Regarding claims 4 and 5, the reference further discloses locking features formed on the flow control structure, wherein the locking features comprise tapered sections formed on the flow control structure to form a choke point in the fill port channel (fig. 8, 740 creates choke point with channel 120).

Regarding claims 24-29, 60 and 61, Michael discloses a package for a microelectromechanical device (MEMS device), comprising: an inner enclosure having an
inner cavity (fig. 2, 100) defined therein; a fill port channel (120) coupling the inner
cavity to an atmosphere; and a flow control structure (fig. 8, 740 and 600) being
configured to control the flow of fluid into the inner cavity comprising a physical
barrier between the fill port channel and a portion of the inner cavity (600) and
extending at least partially into the inner enclosure and comprising a peninsula
(740); further comprising locking features formed on the flow control structure as
tapered sections that form a choke point at an intermediate portion of the fill port
channel (fig. 8, 740 creates choke point with channel 120); and further comprising

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an adhesive in the fill port channel (fig. 9, 900), a fluid filling the inner enclosure (fig. 4, 400) and an airless interface between the fluid and adhesive (fig. 9, airless interface).

Regarding claims 43-47, Michael discloses a method of forming a package for a micro-electromechanical device (MEMS device), comprising: forming an inner enclosure having an inner cavity (fig. 2, 100) defined therein and forming a fill port channel (120), wherein the fill port channel is in fluid communication with an atmosphere and the inner cavity is of sufficient length to allow a variable flow of adhesive to enter the fill port channel while preventing the adhesive from entering the inner cavity; and flowing a quantity of adhesive through a fill port of the fill port channel and into the fill port channel (fig. 9, 900); wherein the fill port channel extends at least partially into the inner enclosure and further comprising forming a flow control structure to form the fill port channel and to physically separate the fill port channel from the inner cavity (fig. 8, 600); wherein the flow control structure further comprises locking features that have a plurality of tapered sections which form a choke point at an intermediate portion of the fill port channel (fig. 8, 740 creates choke point with channel 120).

Regarding claims 54-55, Michael discloses a MEMS package, comprising: means for containing a MEMS device (fig. 2, 100); a fluid (fig. 4, 400) with the MEMS device in the means for containing the MEMS device; means for introducing the fluid into an interior cavity of the means for containing the MEMS device (channel 120); an adhesive flowed into the means for introducing the fluid (fig. 9, 900); and locking means for controlling a flow of the adhesive through the means

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for introducing the fluid as to prevent the adhesive from entering the interior cavity (fig. 8, 740 & 600).

3. Claims 1-3, 24-25 and 43-44 are rejected under 35 U.S.C. 102(e) as being anticipated by Lutz et al. '367.

Regarding claims 1-3, Lutz discloses a package for a micro-electromechanical device (MEMS package), comprising: an inner enclosure having an inner cavity defined therein (fig. 2, cavity 28); and a fill port channel (32) communicating with the inner cavity and of sufficient length to allow a quantity of adhesive to enter the fill port channel while preventing the adhesive from entering the inner cavity (adhesive 34 enters channel but not cavity 28); and further comprising a flow control structure (fig. 7A, trap 60) extending at least partially into the fill port channel and wherein the flow control structure prevents the adhesive from entering the cavity by physically obstructing a portion of the fill port channel (fig. 7A/7B, element 22 obstructs the channel and trap 60 prevents adhesive 34 from entering cavity 28).

Regarding claims 24-25, Lutz discloses a package for a micro-electromechanical device (MEMS device), comprising: an inner enclosure having an inner cavity (fig. 2, 28) defined therein; a fill port channel (32) coupling the inner cavity to an atmosphere; and a flow control structure (fig. 7A, trap 60) extending at least partially into the inner enclosure and being configured to control the flow of fluid into the inner cavity, comprising a physical barrier between the fill port channel and a portion of the inner cavity (fig. 7A/7B, element 22 obstructs the channel and trap 60 prevents adhesive 34 from entering cavity 28).

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Regarding claims 43-44, Lutz discloses a method of forming a package for a micro-electromechanical device (MEMS device), comprising: forming an inner enclosure having an inner cavity (fig. 2, 28) defined therein and forming a fill port channel (32), wherein the fill port channel is in fluid communication with an atmosphere and the inner cavity is of sufficient length to allow a variable flow of adhesive to enter the fill port channel while preventing the adhesive from entering the inner cavity; and flowing a quantity of adhesive through a fill port of the fill port channel and into the fill port channel (34); wherein the fill port channel extends at least partially into the inner enclosure and further comprising forming a flow control structure (fig. 7A, trap 60) to form the fill port channel and to physically separate the fill port channel from the inner cavity (fig. 7A/7B, element 22 obstructs the channel and trap 60 prevents adhesive 34 from entering cavity 28).

Allowable Subject Matter

- 4. Claims 59 and 62 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 5. Claim 32-42 are allowed.
- 6. The following is a statement of reasons for the indication of allowable subject matter: a search of the prior art failed to disclose or reasonably suggest a MEMS package comprising an inner enclosure having an inner cavity defined therein; and a fill port channel communicating with the internal cavity and of sufficient length to allow a quantity of adhesive to enter the fill port channel while preventing the adhesive from entering the inner cavity, and comprising at least one diaphragm

disposed the inner cavity for changing a volume of the inner cavity so as to draw a quantity of the adhesive through the fill port channel, as recited by claim 59.

A search of the prior art also failed to disclose or reasonably suggest a MEMS package comprising an inner enclosure having an inner cavity defined therein; a fill port channel coupling the inner cavity to an atmosphere; and flow control structure extending at least partially into the inner enclosure and being configured to control the flow of fluid into the inner cavity, and comprising at least one diaphragm disposed the inner cavity for changing a volume of the inner cavity so as to draw a quantity of the adhesive through the fill port channel, as recited by claim 62.

A search of the prior art also failed to disclose or reasonably suggest a MEMS assembly, comprising a MEMS device disposed at least partial]y within a package; the package including an inner enclosure having an inner cavity defined therein, and a fill port channel coupling the inner cavity to an atmosphere and physically separating the atmosphere and the inner cavity by a distance sufficient to allow a variable flow of adhesive to enter the fill port channel while preventing the adhesive from entering the inner cavity; an adhesive seal coupled to the fill port channel; and a diaphragm disposed in the inner cavity for changing a volume of the inner cavity so as to draw a quantity of the adhesive seal through the fill port channel, as recited in claim 32.

Conclusion

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Steven J. Fulk whose telephone number is (571)

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272-8323. The examiner can normally be reached on Monday through Friday, 9:30am-6:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Bill Baumeister can be reached on (571) 272-1722. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

8. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

SUF

Steven J. Fulk Patent Examiner Art Unit 2891

November 25, 2007

🦥 WILIJAM BAUMEISTER

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1. SYMPAGGY CENTER 2800